

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 26, 2024

IGI Report Number

LG662462855

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

10.63 X 7.77 X 4.94 MM

GRADING RESULTS

Carat Weight

4.01 CARATS

Color Grade

E

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

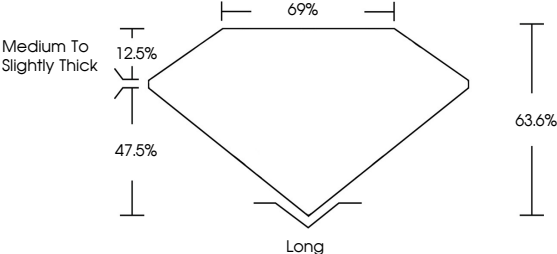
Inscription(s)

 LG662462855

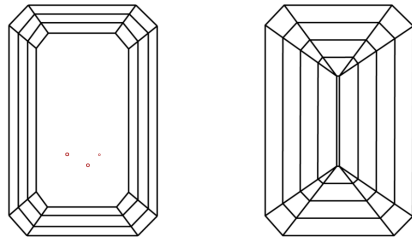
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS



Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY


IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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
Symmetry

EXCELLENT

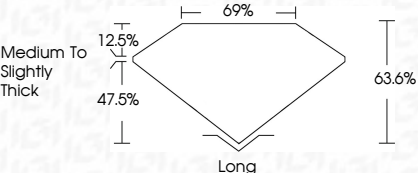
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EMERALD CUT

10.63 X 7.77 X 4.94 MM

4.01 CARATS

E

VS 2

63.6%

69%


Medium to Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

 LG662462855

Cutlet

Polish

Symmetry

Fluorescence

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